

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Omer H. Dokumaci, et al. **Examiner:** Unassigned
Serial No: To be assigned **Art Unit:** Unassigned
Filed: Herewith **Docket:** FIS920030115US1 (16506)
For: NANOCIRCUIT AND SELF-CORRECTING ETCHING METHOD FOR FABRICATING SAME **Dated:** October 28, 2003

Commissioner for Patents
United States Patent Office
Alexandria, VA 23313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. U.S. Patent No. 6,025,273, dated February 15, 2000 issued to Chen et al.; and
2. U.S. Patent Publication No. 2002/0074313A1, published on June 20, 2003 to Hu et al.

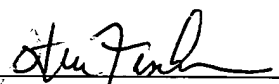
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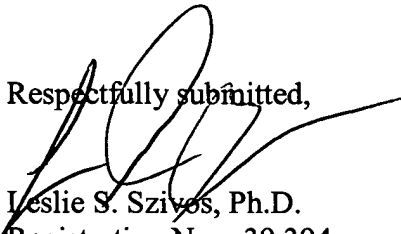
Dated: October 28, 2003


Steven Fischman

In accordance with the schedule set out in 37 C.F.R. § 1.98 (a)(2)(i), applicants are not required to submit a copy of the above-cited U.S. Patent references.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(b), no statement or fee is required.

Respectfully submitted,


Leslie S. Szivos, Ph.D.
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Enclosure PTO Form 1449

Atty. Docket No.
FIS920030115US1 (16506)

Serial No.
To be assigned

**LIST OF PRIOR ART
CITED BY APPLICANT**

(Use several sheets if necessary)

Applicant
Omer H. Dokumaci, et al.

Filing Date
Herewith

Group
Unassigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FLING DATE (if appropriate)
	AA	6,025,273	2/15/2000	Chen et al.			
	AB						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

		U.S. Publication No. 2002/0074313A1, published on June 20, 2002 to Hu et al.

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.